



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/234,233  
Filing Date ..... January 20, 1999  
Inventor ..... Weimin Li, et al  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2818  
Examiner ..... D. Vu  
Attorney's Docket No. .... MI22-1035  
Title: Semiconductor Processing Method

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed together with the filing of the Request for Continued Examination (RCE) Application. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 26 Jun 2002

Attorney: James E. Lake  
Reg. No.: 44,854

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C. S. S. S.  
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